

L Number	Hits	Search Text	DB	Time stamp
-	208	spacer with coat\$ and (445/24 or 313/422 or 313/309)	USPAT	2003/04/28 15:08
-	19	(spacer with coat\$ and (445/24 or 313/422 or 313/309)) and spacer same silicon with (cvd or vapor or DMSDMA or dimethylsilyld\$)	USPAT	2003/04/28 15:19
-	0	(spacer with coat\$ and (445/24 or 313/422 or 313/309)) and spacer same silicon with (cvd or vapor or DMSDMA or dimethylsilyld\$) not ((spacer with coats and (445/24 or 313/422 or 313/309)) and spacer same silicon with (cvd or vapor or DMSDMA or dimethylsilyld\$))	USPAT	2003/04/28 15:19
-	2	spacer same resist and spacer with (cvd or vapor or DMSDMA or dimethylsilyld\$) and display adj panel	USPAT	2003/04/28 15:22
-	0	spacer same resist and posts with (cvd or vapor or DMSDMA or dimethylsilyld\$) and display adj panel	USPAT	2003/04/28 15:22
-	1	spacer same resist and posts with (cvd or vapor or DMSDMA or dimethylsilyld\$) and display adj panel	USPAT	2003/04/28 15:24
-	1	spacer same photoresist and (posts with (cvd or vapor or DMSDMA or dimethylsilyld\$)) and display adj panel	USPAT	2003/04/28 15:27
-	363	313/422 and (CDV or vapor or chemical or deposition)	USPAT	2003/04/28 15:29
-	210	(313/422 and (CDV or vapor or chemical or deposition)) and spacer	USPAT	2003/04/28 15:30